



PATENT
8017-1156

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Akira USUI et al.

Conf. 8975

Application No. 10/519,571

Group 2812

Filed March 9, 2005

Examiner E. Ullah

GROUP III NITRIDE SEMICONDUCTOR SUBSTRATE
AND PROCESS FOR PRODUCTION THEREOF

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 25, 2006

Sir:

In response to the Official Action mailed January 30, 2006, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Amendments to the Drawings begin on page 14 of this paper.

Remarks begin on page 15 of this paper.

An **Appendix**, including one replacement drawing sheet, is attached following the signature page of this paper.